

EE C245 - ME C218 Introduction to MEMS Design Fall 2010

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Lecture Module 2: Benefits of Scaling

E C245: Introduction to MEMS Design

LecM a

C. Nguyer

8/20/09

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Lecture Outline

- Reading: Senturia, Chapter 1
- Lecture Topics:
 - **⇔** Benefits of Miniaturization
 - ♦ Examples
 - → GHz micromechanical resonators
 - ◆ Chip-scale atomic clock
 - Micro gas chromatograph

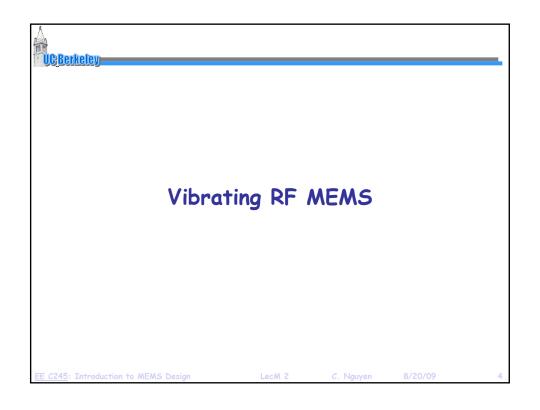
EE C245: Introduction to MEMS Design

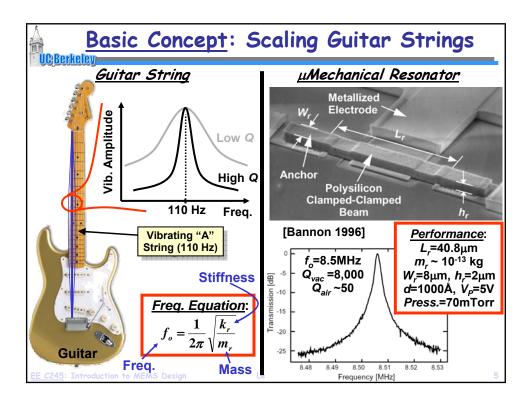
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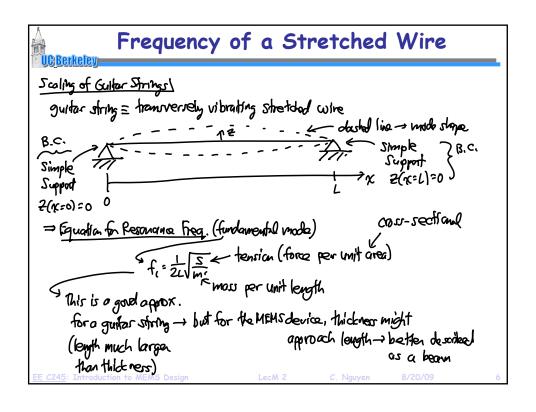
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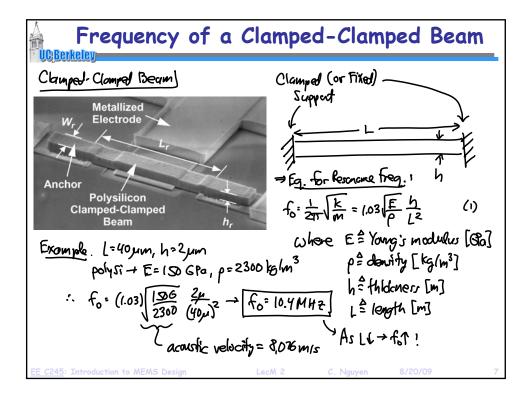
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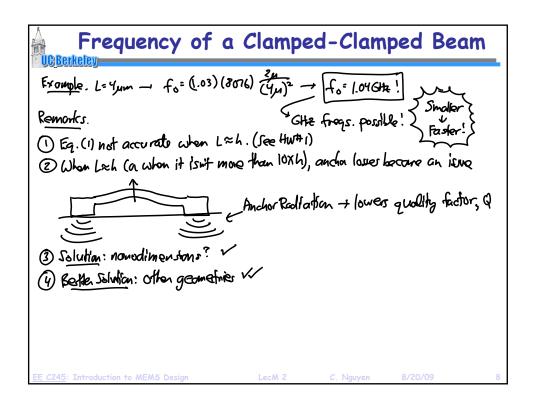
Benefits of Size Reduction: MEMS * Benefits of size reduction clear for IC's in elect. domain Size reduction ⇒ speed, low power, complexity, economy * MEMS: enables a similar concept, but ... MEMS extends the benefits of size reduction beyond the electrical domain Performance enhancements for application domains beyond those satisfied by electronics in the same general categories Speed ⇒ Frequency ↑, Thermal Time Const. ↓ Power Consumption ⇒ Actuation Energy ↓, Heating Power ↓ Complexity ⇒ Integration Density ↑, Functionality ↑ Economy ⇒ Batch Fab. Pot. ↑ (esp. for packaging) Robustness ⇒ g-Force Resilience ↑ Lech 2 C. Nguyen 8/20/09

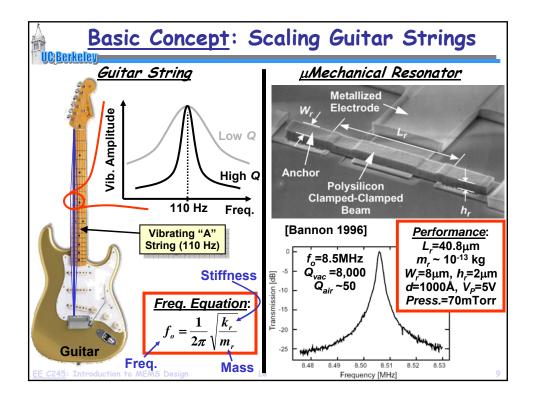


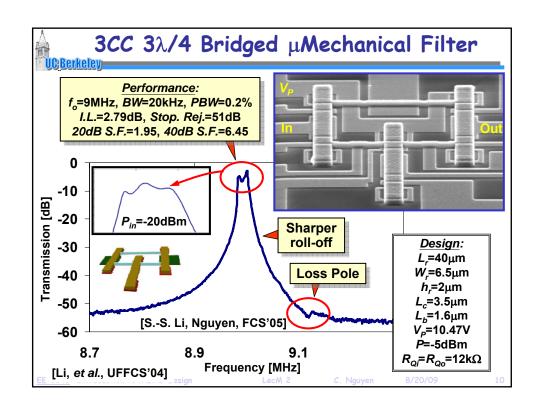


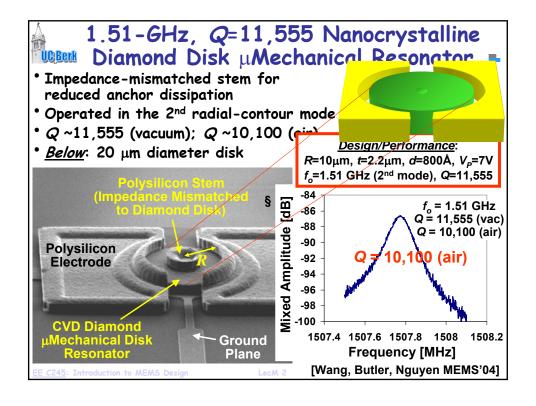


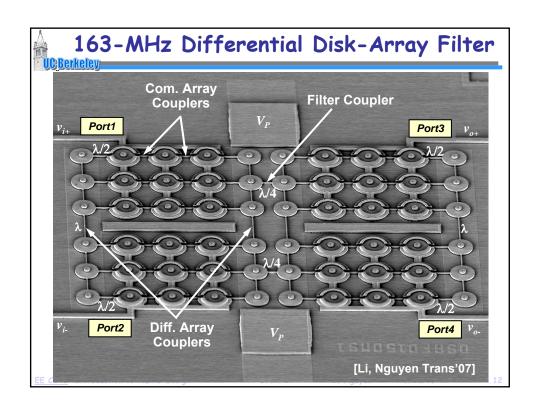


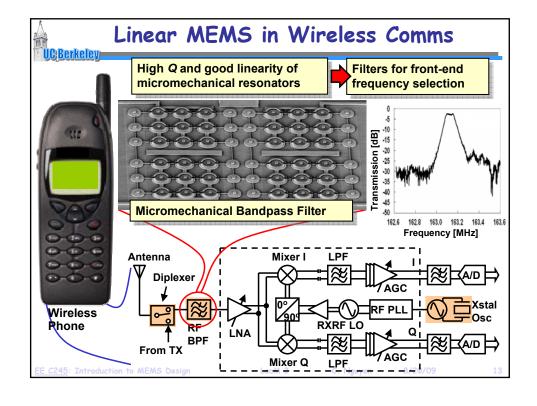


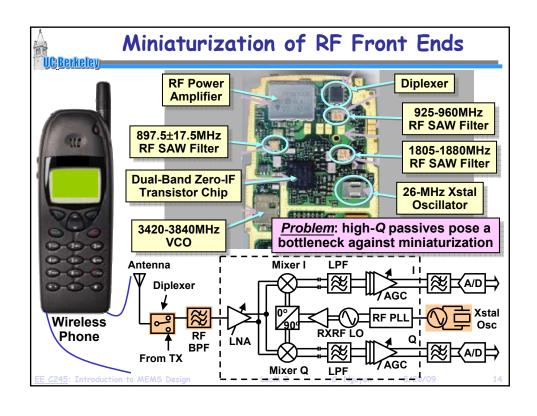


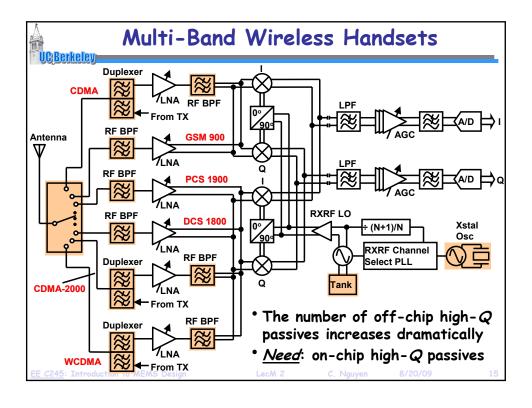


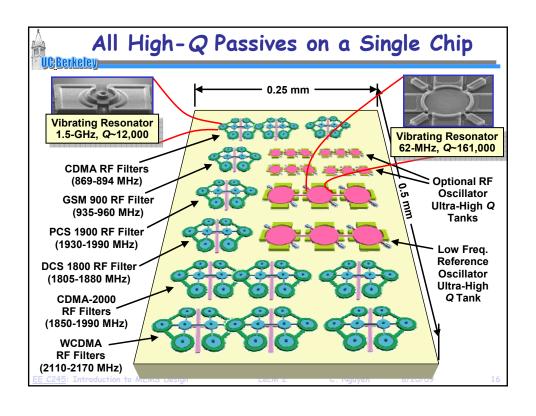


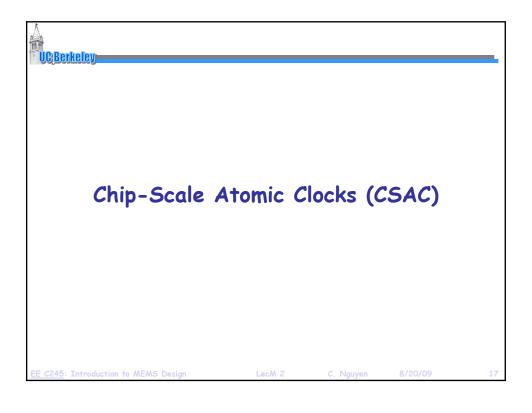


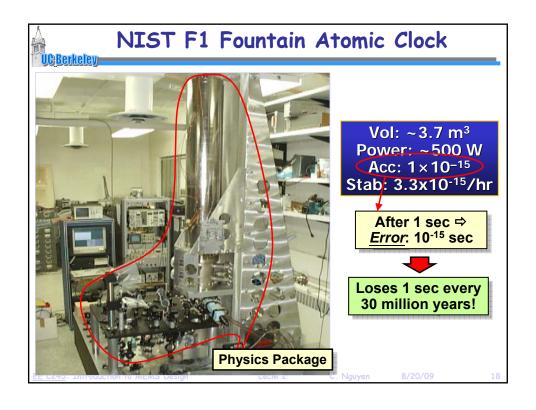


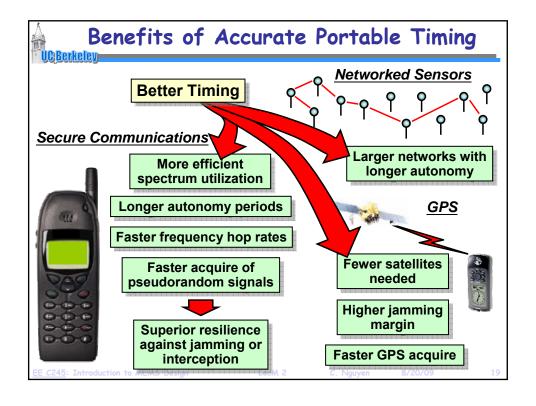


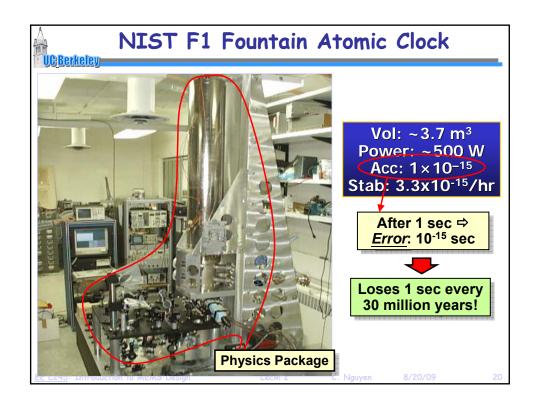


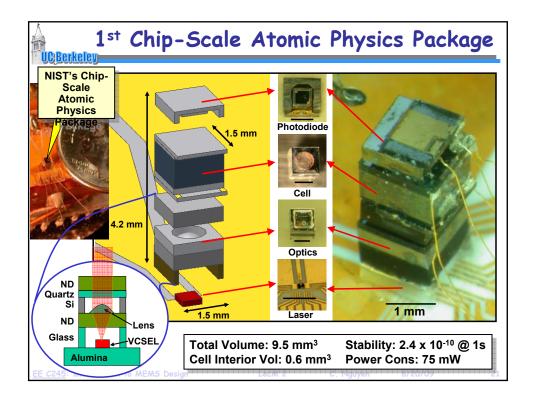


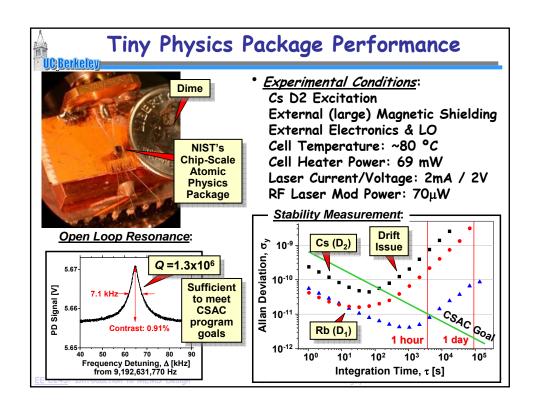


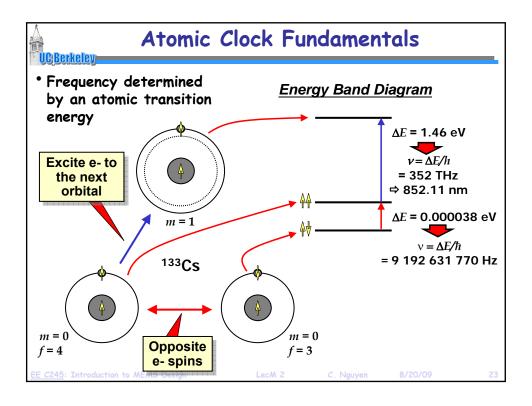


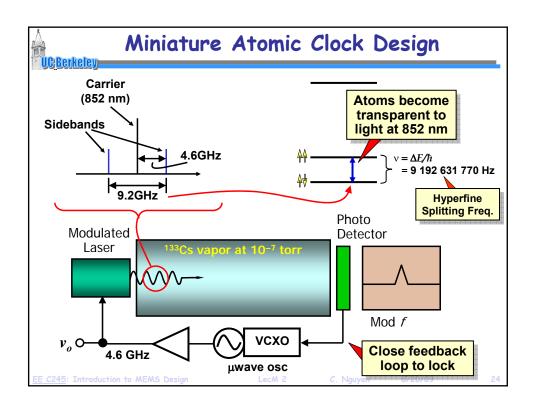


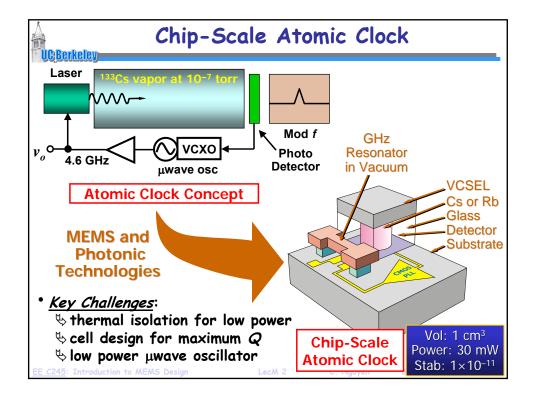


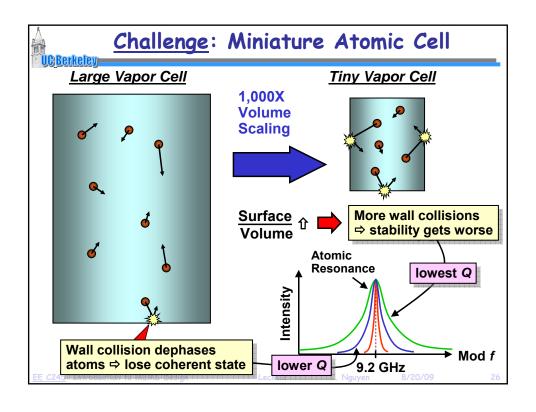


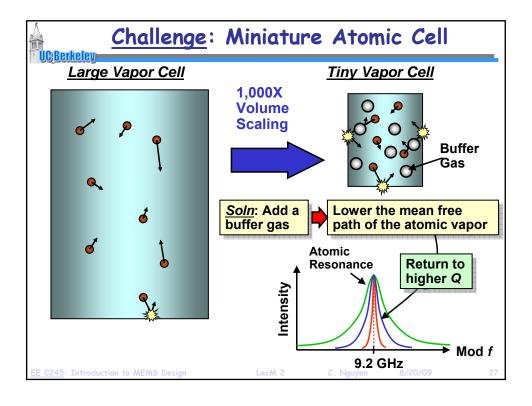


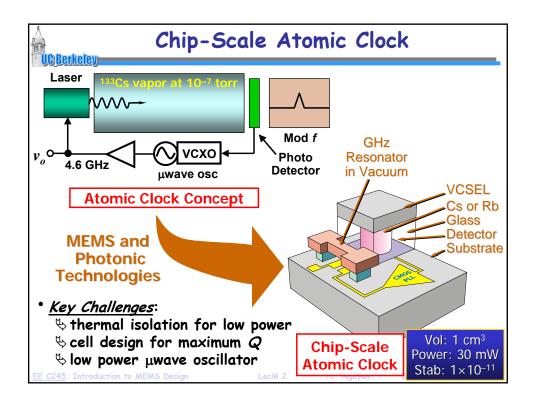


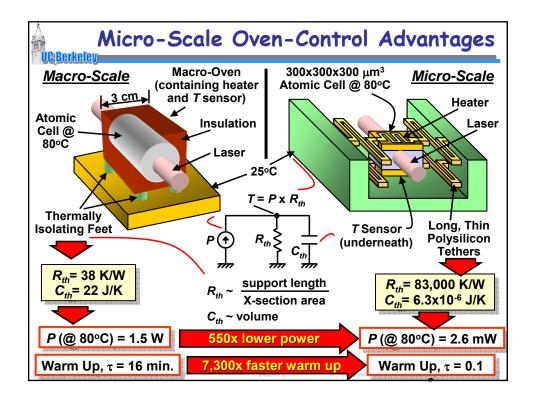


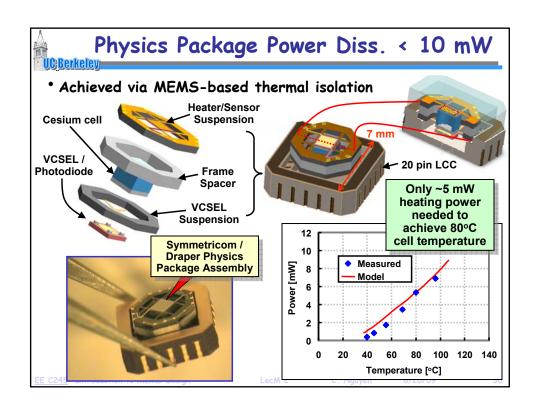


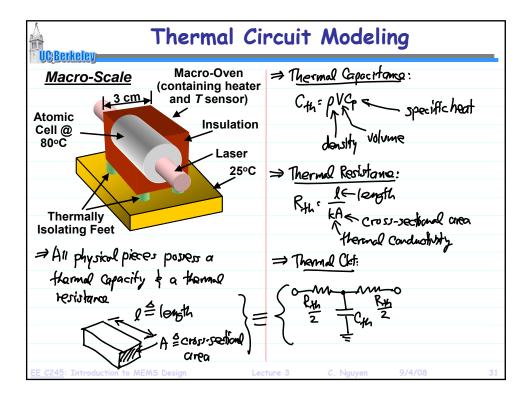


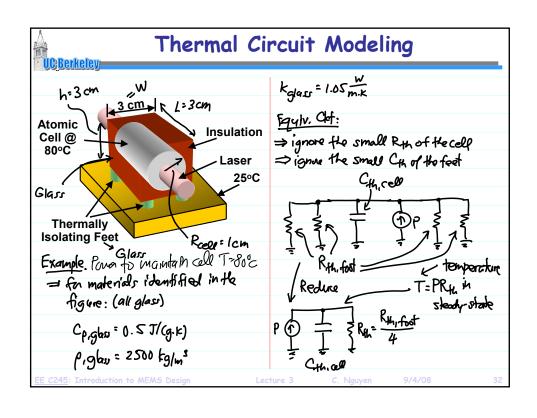


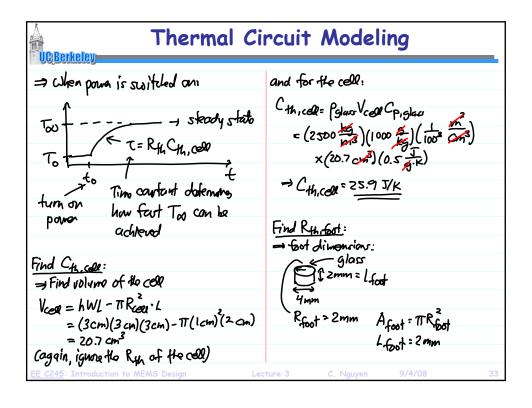


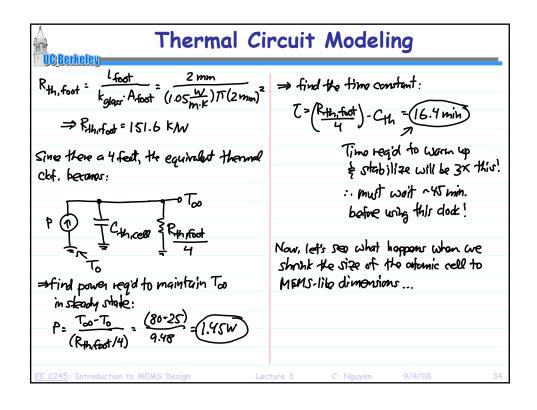


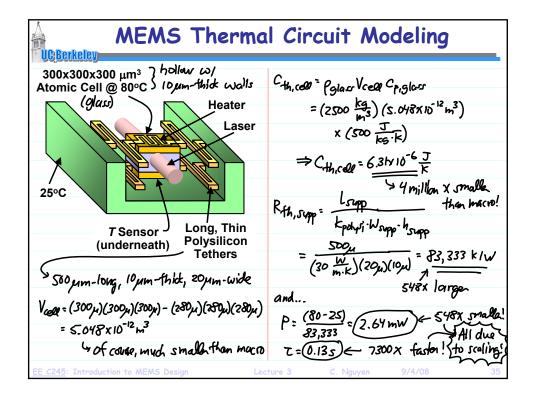


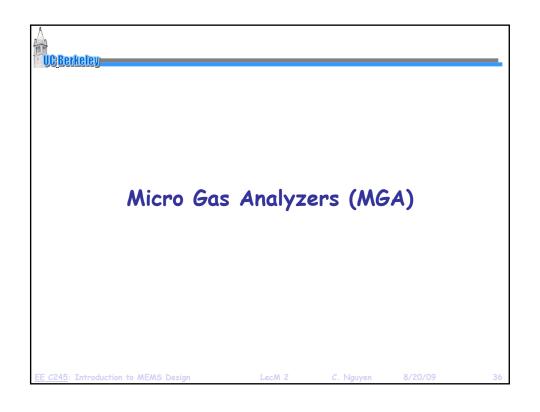


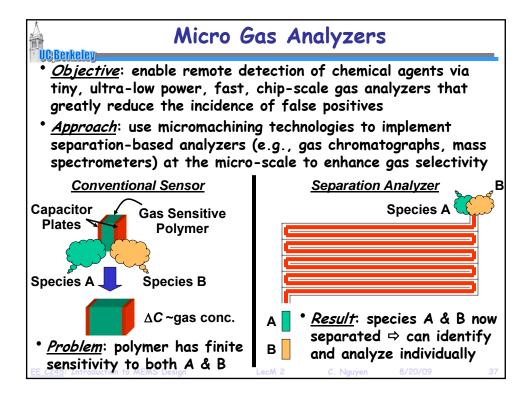


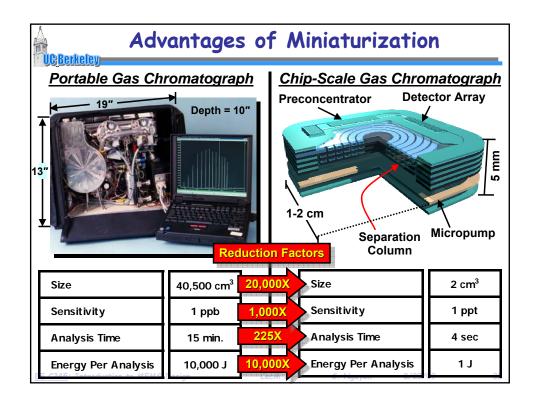


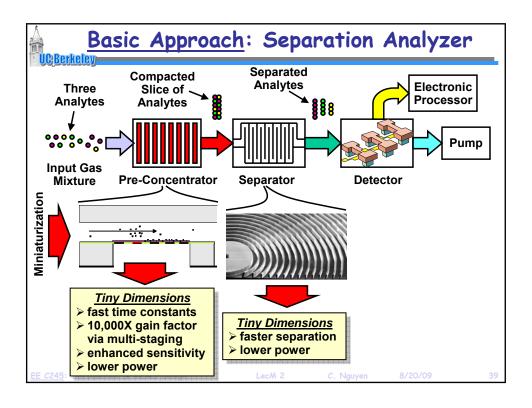


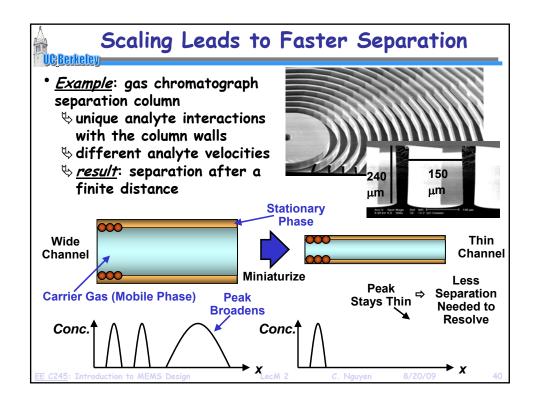


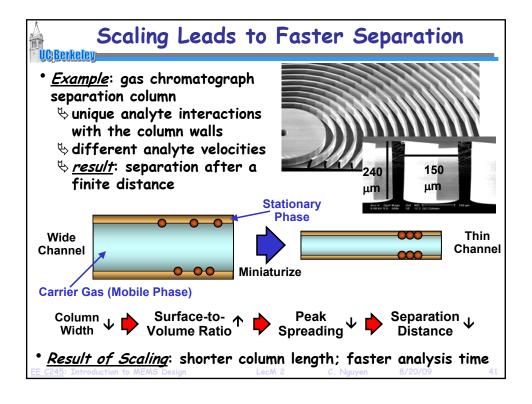


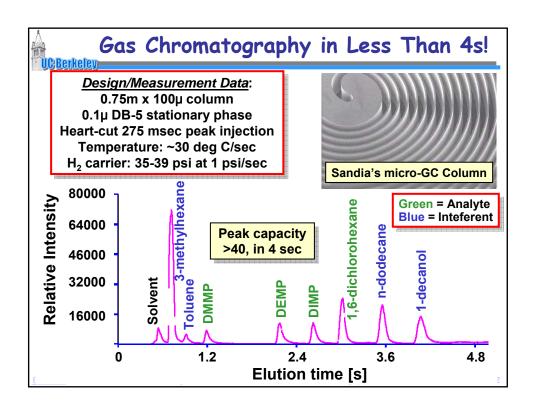


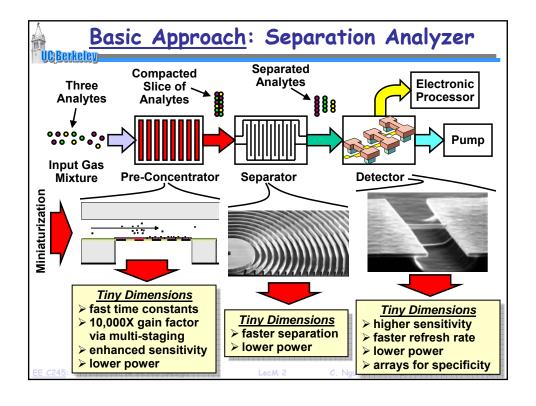


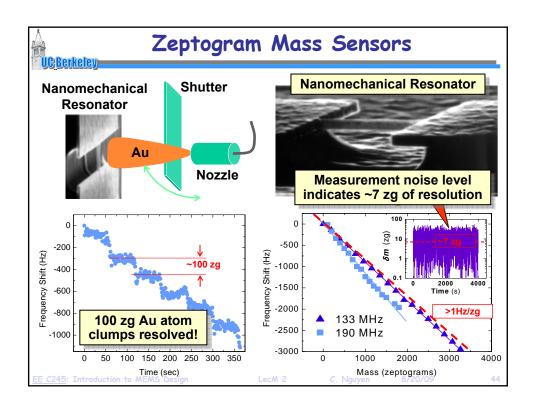


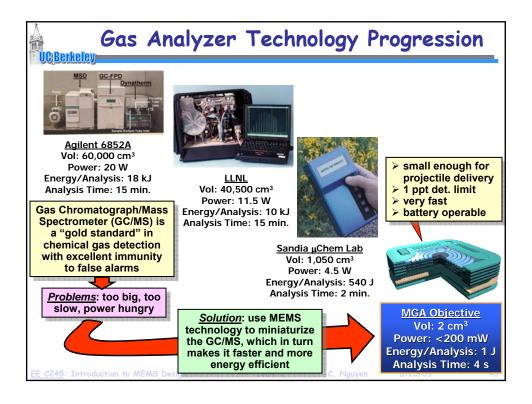


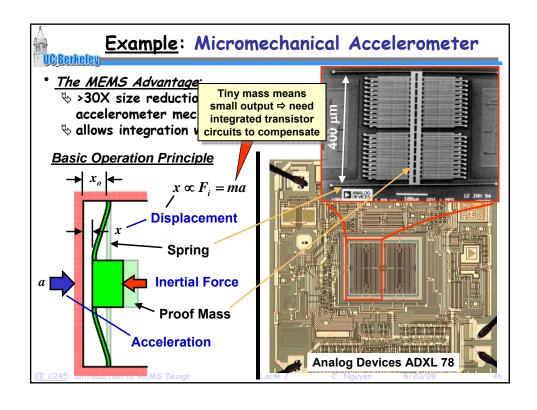












Messages Going Forward ...

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- MEMS are micro-scale or smaller devices/systems that operate mainly via a mechanical or electromechanical means

Size ↓

resonant frequency ↑ (faster speed)
actuation force ↓ (lower power)
mechanical elements ↑ (higher complexity)
integration level ↑ (lower cost)

- * Micro ... nano ... it's all good
- Just as important: MEMS or NEMS have brought together people from diverse disciplines ⇒ this is the key to growth!
- What's next? ⇒ Nano-nuclear fusion? Chip-scale atomic sensors?

... limitless possibilities ...

<u>C245</u>: Introduction to MEMS Design

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